



UNITED STATES PATENT AND TRADEMARK OFFICE

Commissioner for Patents
United States Patent and Trademark Office
Washington, D.C. 20231
www.uspto.gov
DW 12-01

Paper No. 5

LEE & HAYES PLLC
421 W RIVERSIDE AVENUE SUITE 500
SPOKANE, WA 99201

COPY MAILED

DEC 14 2001

OFFICE OF PETITIONS

In re Application of :
Zintel, Gandhi, Gu, Pather, :
Schlimmer, Rude, Weisman, Ryan, : DECISION ACCORDING STATUS
Leach, Cai, Knight, and Ford : UNDER 37 CFR 1.47(a)
Application No. 09/811,362 :
Filed: 16 March, 2001 :
Attorney Docket No. MSI-785US :

This is in response to the petition filed under 37 CFR 1.47(a) on 2 August, 2001.

The petition is **GRANTED**.

Petitioner has shown that the non-signing inventor, Christopher M. Rude, has refused to join in the filing of the above-identified application after having been sent a copy of the application papers. Specifically, the declaration of petitioners' registered patent attorney, Lewis C. Lee, establishes that the inventor was sent two copies of the application, but has failed to sign and return the declaration naming him as a joint inventor along with William M. Zintel, Amar S. Gandhi, Ye Gu, Shyamalan Pather, Jeffrey C. Schlimmner, Daniel R. Weisman, Donald R. Ryan, Paul J. Leach, Ting Cai, Holly N. Knight, and Peter S. Ford.

The above-identified application and papers have been reviewed and found in compliance with 37 CFR 1.47(a). This application is hereby accorded Rule 1.47(a) status.

As provided in Rule 1.47(c), this Office will forward notice of this application's filing to the non-signing inventor at the address given in the declaration. Notice of the filing of this application will also be published in the Official Gazette.

The application is being forwarded to Technology Center 2100 for examination in due course.

Telephone inquiries related to this decision should be directed to the undersigned at 703-308-6918.

A handwritten signature in cursive script, appearing to read "D. Wood".

Douglas I. Wood
Petitions Attorney
Office of Petitions
Office of the Deputy Commissioner
for Patent Examination Policy